US 20070017633A1

(19) United States

(12) Patent Application Publication

(10) Pub. No.: US 2007/0017633 A1

(43) Pub. Date: Jan. 25, 2007

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(54) SURFACE FEATURES IN MICROPROCESS TECHNOLOGY

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(21) Appl. No.: **11/388,792**

(22) Filed: **Mar. 23, 2006**

Related U.S. Application Data

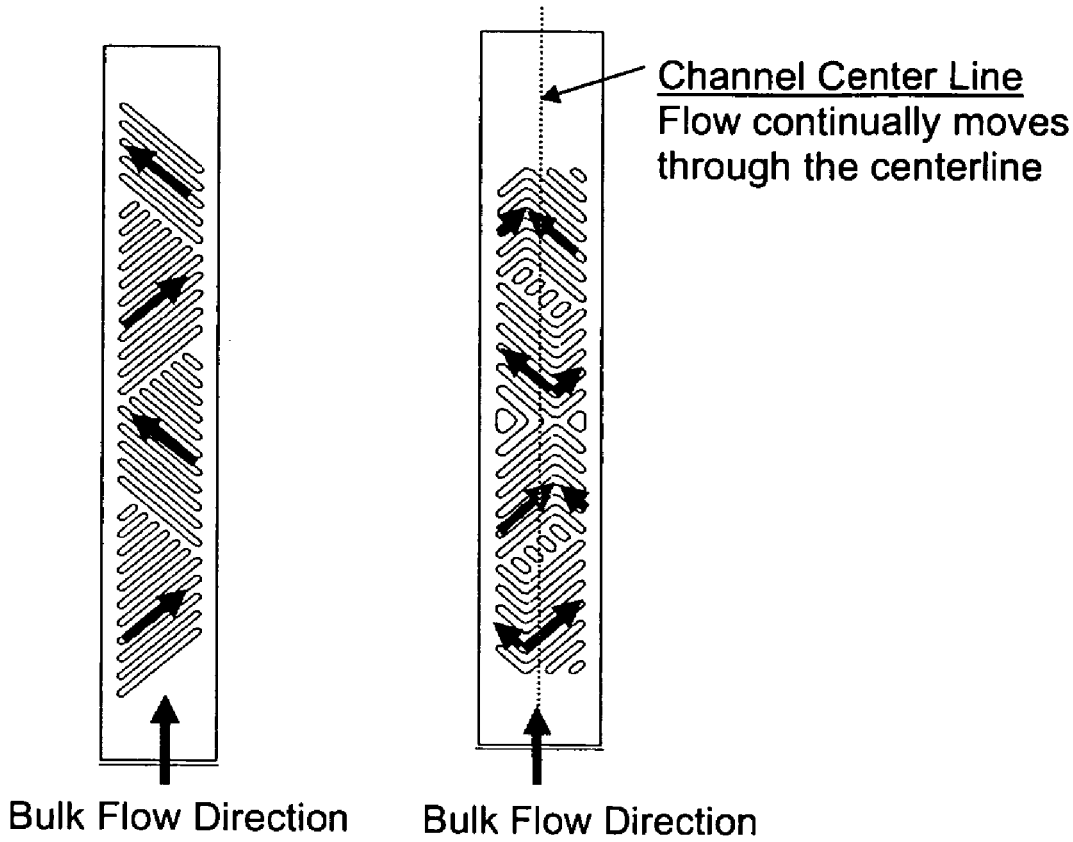
(63) Continuation-in-part of application No. 11/089,440, filed on Mar. 23, 2005.

(60) Provisional application No. 60/697,900, filed on Jul. 8, 2005. Provisional application No. 60/727,126, filed on Oct. 13, 2005. Provisional application No. 60/731,596, filed on Oct. 27, 2005.

Publication Classification

(51) **Int. Cl.**
B32B 37/00 (2006.01)

(52) **U.S. Cl.** **156/300**; 366/341

(57) **ABSTRACT**

This invention relates to microchannel apparatus that includes microchannels with interior surface features for modifying flow; processes utilizing this microchannel architecture, and methods of making apparatus having these features.